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Electronic Tongues

Guest Editor:

Prof. Dr. Manel del Valle

Sensors & Biosensors Group,
Department of Chemistry,
Universitat Autònoma de
Barcelona, Edifici Cn, Campus de
Bellaterra (Cerdanyola del
Vallés), 08193 Barcelona, Spain

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Message from the Guest Editor

Electronic tongues represent a new operational procedure in the sensor field that entails the use of chemical sensor arrays coupled with chemometric processing tools, as a mean to improve sensors performance. This approach is in tune with modern use of intelligent data processing as the way to improve automatic and or robotic operation. The most singular applications being developed pertain to the food and beverage field, the environmental or agricultural field and the pharmaceutical field; it is also worth mentioning the attempts to mimic the animal or human taste perceptions, with systems known as artificial taste systems.



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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Message from the Editor-in-Chief

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Micromachines Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

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